

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Shuji HAHAKURA, et al.

Title: METHOD OF PRODUCING
OXIDE SUPERCONDUCTING
FILM (AS AMENDED)

Appl. No.: 10/511,268

International 4/17/2003
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Confirmation 6578
Number:

AMENDMENT AND REPLY UNDER 37 CFR 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
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Sir:

This communication is responsive to the Final Office Action dated August 14, 2008, concerning the above-referenced patent application, making October 14, 2008, two-months from the mailing date. Accordingly, the response is timely filed within the advisory period.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 5 of this document.

Please amend the application as follows: